

Notice of References Cited	Application/Control No. 10/534,700		Applicant(s)/Patent Under Reexamination WITTMER ET AL.	
	Examiner JUNCHUN WU		Art Unit 2191	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	"PROFIBUS technology and application – system description", Oct. 2002
	V	Diedrich et al., "Field Device Integration in DCS Engineering using a Device Model", 1998, IEEE, pp.164-168
	W	Poschmann et al., "Experience with formal methods implementing the PROFIBUS FMS and DP protocol for industrial applications", 1997, IEEE pp.277-286
*	X	Simon et al., "Field Device Integration", 2001, IEEE

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.